## We claim:

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1. An inspection device for inspecting projections on a substrate such as bumps on microelectronics such as semiconductors:

CLAIMS

- a light source; and
- a non-laser confocal sensor.
- 2. The inspection device of claim 1 further comprising a camera for collecting focused light.
- 3. The inspection device of claim 2 wherein the non-laser confocal sensor includes a pellicle beamsplitter for receiving light from the light source and redirecting said light.
- 4. The inspection device of claim 3 wherein the non-laser confocal sensor includes an aperture array for receiving light from the pellicle beamsplitter.
- 5. The inspection device of claim 3 wherein the non-laser confocal sensor includes a dual telecentric object reimager including a plurality of lenses;)
- 6. The inspection device of claim 3 wherein the non-laser confocal sensor includes a telecentric camera imager including a plurality of lenses.
- 7. The inspection device of claim 3 wherein the non-laser confocal sensor includes:

an aperture array for receiving light from the pellicle beamsplitter; a dual telecentric object reimager including a plurality of lenses; and a telecentric camera imager including a plurality of lenses.

- 8. An inspection device for inspecting projections on a substrate such as bumps on microelectronics such as semiconductors:
  - a light source; and a white light confocal sensor.

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- 9. The inspection device of claim 8 further comprising a camera for collecting focused light.
- 10. The inspection device of claim 9 wherein the confocal sensor includes a pellicle beamsplitter for receiving light from the light source and redirecting said light.
- 11. The inspection device of claim 10 wherein the confocal sensor includes an aperture array for receiving light from the pellicle beamsplitter.
- 12. The inspection device of claim 10 wherein the confocal sensor includes a dual telecentric object reimager including a plurality of lenses() ?
- 13. The inspection device of claim 10 wherein the confocal sensor includes a telecentric camera imager including a plurality of lenses.
- 14. The inspection device of claim 10 wherein the confocal sensor includes:

an aperture array for receiving light from the pellicle beamsplitter; a dual telecentric object reimager including a plurality of lenses; and a telecentric camera imager including a plurality of lenses.

- 15. The inspection device of claim 10 wherein light source is one of a halogen light source, an arc light, light emitting diodes including white or colored light emitting diodes, and fluorescent lights.
- 16. An inspection device for inspecting projections on a substrate such as bumps on microelectronics such as semiconductors:

a non-laser light source; and a confocal sensor.

- 17. The inspection device of claim 16 further comprising a camera for collecting focused light, and a pellicle beamsplitter for receiving light from the light source and redirecting said light.
  - 18. The inspection device of claim 17 wherein the confocal sensor

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## includes:

an aperture array for receiving light from the pellicle beamsplitter; a dual telecentric object reimager including a plurality of lenses; and a telecentric camera imager including a plurality of lenses.

- 19. The inspection device of claim 18 wherein light source is one of a halogen light source, an arc light, light emitting diodes including white or colored light emitting diodes, and fluorescent lights.
- 20. The inspection device of claim 16 wherein light source is one of a halogen light source, an arc light, light emitting diodes including white or colored light emitting diodes, and fluorescent lights.